

QUERY CONTROL FORM

'RTIS USE ONLY

Application No. 10/053,576
Examiner-GAU DOUGHERTY-2834

Prepared by NFB
Date 3/10/04
No. of queries .

Tracking Number 05899150
Week Date 2/2/04
IPW

JACKET

a. Serial No.	f. Foreign Priority	k. Print Claim(s)	p. PTO-1449
b. Applicant(s)	g. Disclaimer	l. Print Fig.	q. PTOL-85b
c. Continuing Data	h. Microfiche Appendix	m. Searched Column	r. Abstract
d. PCT	i. Title	n. PTO-270/328	s. Sheets/Figs
e. Domestic Priority	j. Claims Allowed	o. PTO-892	t. Other

SPECIFICATION

- a. Page Missing
- b. Text Continuity
- c. Holes through Data
- d. Other Missing Text
- e. Illegible Text
- f. Duplicate Text
- g. Brief Description
- h. Sequence Listing
- i. Appendix
- j. Amendments
- k. Other

CLAIMS

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- b. Improper Dependency
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MESSAGE

① pp-1449: Please either initial or line through citations. (copy provided for reference).

(2) On page 25 of specification, there are two (2) FIG. 58 (b) - no FIG. 58 (a).

please advise.

Thankyou

initials 

RESPONSE

initials

of the semiconductor microrelay in FIG. 41;

FIG. 50 is a relation drawing used to describe the function of the semiconductor microrelay in FIG. 41;

FIG. 51 is a relation drawing used to describe the function of the semiconductor microrelay in FIG. 41;

FIG. 52 is a partially cutaway view in perspective of the structure of another semiconductor microrelay;

FIG. 53 is a top view to show the structure of a semiconductor microactuator in a related art;

FIG. 54 is a sectional view to show the structure of the semiconductor microactuator in the related art;

FIG. 55 is a sectional view to show the structure of a semiconductor microrelay in a related art; and

FIG. 56 is a schematic drawing used to describe the function of the semiconductor microrelay in the related art.

FIG. 57 is a partially cutaway view in perspective of the structure of a semiconductor microactuator using a semiconductor device corresponding to another embodiment of the invention;

FIG. 58 (b) is a sectional view to show the structure of the semiconductor microactuator in FIG. 57;

FIG. 58(b) is a top view to show the structure of the semiconductor microactuator in FIG. 57;

FIG. 59 is a partially cutaway view in perspective of the structure of a semiconductor microactuator using a semiconductor device corresponding to another embodiment of the invention;